

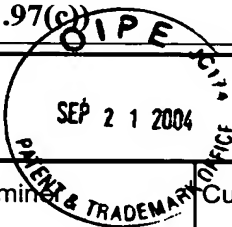
IFW

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))				Docket No. SEC.1085	
In Re Application Of: Dong-Seok Ham et al.					
Application No. 10/684,439	Filing Date 10/15/2003	Examiner TBA	Customer No. 20987	Group Art Unit 3752	Confirmation No. 3932
Title: CONTAMINATION CONTROL METHOD AND APPARATUS, AND AIR-CONDITIONING SYSTEM OF A SUBSTRATE PROCESSING FACILITY EMPLOYING THE SAME					
Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450					
37 CFR 1.97(b)					
1. <input checked="" type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.					
37 CFR 1.97(c)					
2. <input type="checkbox"/> The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:					
<input type="checkbox"/> the statement specified in 37 CFR 1.97(e);					
OR					
<input type="checkbox"/> the fee set forth in 37 CFR 1.17(p).					

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
SEC.1085

In Re Application: **Dong-Seok Ham et al.**



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Title: **CONTAMINATION CONTROL METHOD AND APPARATUS, AND AIR-CONDITIONING
SUBSTRATE PROCESSING FACILITY EMPLOYING THE SAME**

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

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- ☐ The Director is hereby authorized to charge and credit Deposit Account No. _____ as described below.
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Dated: **SEPT. 21, 2004**

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INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

Docket Number (Optional)
SEC.1085

Application Number
10/684,439

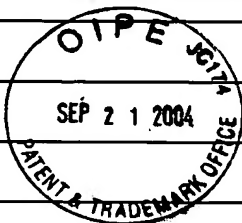
Applicant(s)
Deong-Seok Ham et al.

Filing Date
10/15/2003

Group Art Unit
3752

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE



U.S. PATENT APPLICATION PUBLICATIONS

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FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
	A	11-74168	03/16/1999	JAPAN			✓	
	B	11-74193	03/16/1999	JAPAN			✓	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.